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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Akira Ishikawa  
Serial No. : 10/728,903  
Filed : December 8, 2003  
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Art Unit : 2826  
Examiner : Tuan N. Quach  
Confirmation No.: 9311

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

Responsive to the action mailed June 28, 2005, applicant elects the invention of Group I (claims 56-72), drawn to a method of making a semiconductor device. The election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 28, 2005

  
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